

0834-0198-3



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

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TC 1700 #17/m
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IN RE APPLICATION OF: :
YOSHIROU KUROMITSU ET AL. : GROUP ART UNIT: 1714
SERIAL NO: 09/240,858 :
FILED: FEBRUARY 1, 1999 : EXAMINER: MEDLEY, M.
CPA FILED: MAY 30, 2002

FOR: METHOD OF FORMING CERAMIC
CAPILLARY RIB, CERAMIC PASTE
USED THEREFOR, AND APPARATUS
FOR FORMING SAME

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action dated January 16, 2003, please amend the above-identified application, without prejudice, as follows:

IN THE SPECIFICATION

Page 3, lines 8-12- please replace the paragraph with the following text:

A'
The second conventional forming method is shown in Fig. 23, in which it is necessary to make a coating of a photosensitive film for forming the resist layer, and to carry out complicated steps such as exposure and development. Another inconvenience is that removal of most of the pattern forming layer by sand blasting requires a large amount of material for the pattern forming layer.

Page 7, lines 2-22, please replace the paragraph with the following text: